## INFORMATION DISCLOSURE STATEMENT

**Applicant** 

Kamal Kishore Goundar, et al.

App. No.

Unknown

Filed

Herewith

For

METHOD OF MANUFACTURING

SILICON CARBIDE FILM

Examiner

Unknown

Group Art Unit

Unknown

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Enclosed is form PTO-1449 listing fifteen (15) references that are of record in U.S. patent application No. 10/682,180, filed October 9, 2003, which is the parent of this continuation-in-part application, and is relied upon for an earlier filing date under 35 U.S.C. § 120. Copies of the references are not submitted pursuant to 37 C.F.R. § 1.98(d).

This Information Disclosure Statement is being filed with an RCE or within three months of the filing date of this application and no fee is required in accordance with 37 C.F.R. § 1.97(b)(1), (b)(2), or (b)(4).

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated:

November 25, 2003

\_By:\_

Katsuhiro Arai

Registration No. 43,315

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FORM PTO-144	9
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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE ATTY. DOCKET NO. ASMJP.133CP1

APPLICATION NO. Unknown

## INFORMATION DISCLOSURE STATEMENT

BY APPLICANT

**APPLICANT** 

Kamal Kishore Goundar, et al.

(USE SEVERAL SHEETS IF NECESSARY)

**GROUP** FILING DATE Unknown Herewith

U.S. PATENT DOCUMENTS								
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)	
	1	5,800,878	09/01/98	Yoa				
	2	6,187,691	02/13/01	Fukuda et al.				
	3	6,211,077	04/03/01	Shimizu et al.				
	4	6,235,112	05/22/01	Satoh				
	5	6,242,278	06/05/01	Shimizu et al.				
:	6	6,277,201	08/21/01	Nishikawa				
	7	6,383,900	05/07/02	Shimizu et al				
	8	6,524,955	02/25/03	Fukuda et al.				
	9	6,537,928	03/25/03	Matsuki et al.				
	10	2001/0030369 A1	10/18/01	MacNeil et al.		1		
	11	2002/0027286 A1	030/7/02	Sundararajan et al.				
	12	2001/0051445 A1	12/13/01	Shioya et al.				
. =	13	2001/0031563 A1	10/18/01	Shioya et al.				
	14	2002/0054962 A1	05/09/02	Huang				

FOREIGN PATENT DOCUMENTS										
EXAMINER		DOCUMENT NUMBER	DATE	COUNTRY		CLASS	SUBCLASS	TRA	TRANSLATION	
INITIAL								YES	NO	
	15	2001-060584	06/03/01	Japan (English Abstract)						
	16									
	17						·			
	18									

EXAMINER INITIAL	OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)	
	19	·
	20	

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**EXAMINER** DATE CONSIDERED

\*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.